

FORM PTO-1449 (REV.7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 97-P-149D1 (850063.518D1)		EXPRESS MAIL NO. EL897859635US	
<b>INFORMATION DISCLOSURE STATEMENT</b> <i>(Use several sheets if necessary)</i>				APPLICANT Ming Michael Li			
				FILING DATE February 6, 2002		GROUP ART UNIT 2825	
<b>U.S. PATENT DOCUMENTS</b>							
*EXAMINER INITIAL	AA	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
RNR	AA	5,182,232	01/26/93	Chhabra et al.	437	200	
RNR	AB	5,394,012	02/28/95	Kimura	257	739	
RNR	AC	5,418,188	05/23/95	Harper et al.	437	200	
RNR	AD	5,585,295	12/17/96	Wu	437	44	
RNR	AE	5,599,746	02/04/97	Lur et al.	437	200	
RNR	AF	5,767,013	06/16/98	Park et al.	438	622	
RNR	AG	5,877,063	03/02/99	Gilchrist	438	398	
RNR	AH	5,993,685	11/30/99	Currie et al.	252	79.1	
RNR	AI	6,074,926	06/13/00	Cathey et al.	438	398	
	AJ						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
	AK						
	AL						
	AM						
	AN						
	AO						
<b>OTHER PRIOR ART</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
RNR	AP	Chang, C.Y. and Sze, S.M., "ULSI Technology," 1996, The McGraw-Hill Companies, Inc., pp. 229, 395-397					
RNR	AQ	Wolf, S., "Silicon Processing for the VLSI Era," Vol. 2 - Process Integration, 1990, Lattice Press, pp. 45, 354-357					
	AR						
EXAMINER <i>Quito N. Roach</i>				DATE CONSIDERED 9/29/2004			
* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).							